1004 4988879.pn. 2004/02/26 13:4 2004/02	-	2	4988879.pn. 5326633.pn.	US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/02/26 15:46 2004/02/26 13:47 2004/02/26 13:48
PPO, IPO, DERWENT USPAT; US-PGPUB; PPO, IPO, DERW	-	2	5326633.pn.	EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	
DERWENT USPAT; US-PGPUB; EPO, IPO, DERWENT US-PGPUB; EPO	-	2	5326633.pn.	DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	
2 4988879.pn. USPAT, US-PGPUB, EPO, IPO, DERWENT USPAT, TOUGhness) 2004/02/26 13:4 2004/02/26 1	-	2	5326633.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	
US-PGPUB; EPO, JPO; DERWENT USPAT; US-PGPUB; EPO, J	-	2	5326633.pn.	US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	
- 2 5326633.pn. EPO, JPO, DERWENT USPAT, US-PGPUB, EPO, JPO, DERWENT USPAT, US-	-			EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/02/26 13:48
DERWENT USPAT; US-PGPUB; EPO, JPO, DERWENT USPAT; USPATUB; EPO, JPO, DERWENT USPAT;	-			DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/02/26 13:48
2 5326633.pn. USPAT; US-PGPUB; EPO; PPO; DERWENT USPAT; US-PGPUB; EPO; PPO; PPO; PPO; PPO; PPO; PPO; PPO	-			USPAT; US-PGPUB; EPO; JPO;	2004/02/26 13:48
Soft Surface substrate With (("not" near porous) non-porous) US-PGPUB; EPO; IPO; DERWENT USPAT; US-PGPUB; EPO; IP	-			US-PGPUB; EPO; JPO;	2004/02/26 13:48
Sof	-	8507	(surface substrate) with (("not" near porous) non-porous)	ЕРО; ЈРО;	
DER WENT USPAT; USP-CPUB; EPC, IPC, DER WENT USP-CPUB; EPC, IPC, I	-	8507	(surface substrate) with (("not" near porous) non-porous)		
- 1004 ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness) with (("not" near porous) non-porous)) and (rough roughness) and ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4) ((surface substrate) with (("not" near porous) non-porous)) and laser ((surface substrate) with (("not" near porous) non-porous)) and laser (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (surface substrate) with (("not" near porous) non-porous)) and (surface substrate) with (("not" near porous) non-porous)) and (surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with ("sot" near porous) non-porous) and (rough roughness)) and ((surface substrate) with ("sot" near porous) non-porous) and (rough roughness)) and ((surface substrate) with ("sot" near porous) non-porous) and (rough roughness)) and ((surface substrate) with ("sot" near porous) non-porous) and (rough roughness) and (rough roughness	-	8507	(surface substrate) with (("not" near porous) non-porous)	بين ميلاية كاذاكا	
1004 ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness) ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 EPO, IPO, DERWENT USPAT; US-PGPUB; EPO, IPO, DERWENT USPAT	-	8507	(surface substrate) with (("not" near porous) non-porous)		
- 1560 ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness) - 1560 ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 (besor\$5 ioniz\$4) - 1009 ((surface substrate) with (("not" near porous) non-porous)) and laser ((surface substrate) with (("not" near porous) non-porous)) and laser ((surface substrate) with (("not" near porous) non-porous)) and laser (((surface substrate) with ("not" near porous)) and (rough roughness)) and ((surface substrate) with ("not" near porous)) and (rough roughness)) and ((surface substrate) with ("not" near porous)) and (rough roughness)) and ((surface substrate) with ("not" near porous)) and (rough roughness)) and ((surface substrate) with ("not" near porous)) and (rough roughness)) and ((surface substrate) with ("not" near porous)) and (rough roughness)) and ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and analyte (15.2 ((surface substrate) with ("not" near porous)) and ((surface substrate) with ("not" near porous)) and (surface substrate) with ("not" near porous) (surface substrate) with ("surface					2004/02/27 13:53
1004 ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness) 1560 ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 ((surface substrate) with (("not" near porous) non-porous)) and laser USPAT; US-PGPUB; EPO; IPO; DERWENT USPAT; US					
1004 ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness) ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 ((surface substrate) with (("not" near porous) non-porous)) and laser USPAT; US-PGPUB; EPO, IPO, DERWENT US-PGPUB; EPO, IPO, DER					
Toughness Coughness Coug					
1560 ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 (usurface substrate) with (("not" near porous) non-porous)) and laser (usurface substrate) with (("not" near porous) non-porous)) and laser (usurface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and ((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4) and ((surface substrate) with (("not" near porous) non-porous)) and analyte (usurface substrate) (usurface substrate)	-	1004			2004/02/26 18:56
DERWENT USPAT; 2004/02/26 18:5 DERWENT USPAT; 2004/02/26 18:5 DERWENT USPAT; 2004/02/26 18:5 DERWENT USPAT; US-PGPUB; EPO, JPO; DERWENT USPAT; US-PGPUB; EPO, JPO; DERWENT USPAT; USPGPUB; EPO, JPO; DERWENT USPAT;			roughness)		
- 1560 ((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 (USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT					
desor\$5 ioniz\$4)					
1009 ((surface substrate) with (("not" near porous) non-porous)) and laser EPO, IPO, DERWENT USPAT; US-PGPUB; EPO,	-	1560		USPAT;	2004/02/26 18:57
- 1009 ((surface substrate) with (("not" near porous) non-porous)) and laser - 65 (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough with (("not" near porous) non-porous)) and ((surface substrate) with (("surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough non-porous)) and (surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("surface substrate) with ("surface subst			desor\$5 ioniz\$4)		
- 1009 ((surface substrate) with (("not" near porous) non-porous)) and laser (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (((surface substrate) with ("not" near porous)) and (rough roughness)) and ((((surface substrate) with ("not" near porous)) and (rough roughness)) and ((((surface substrate) with ("not" near porous)) and (rough roughness)) and ((((surface substrate) with ("not" near porous)) and (rough roughness)) and (((surface substrate) with ("not" near porous)) and (rough roughness)) and (((surface substrate) with ("not" near porous)) and (rough roughness)) and (((surface substrate) with ("not" near porous)) and (rough roughness)) and ((rough roughness)) and (((surface substrate) with ("not" near porous)) and (rough roughness))				ЕРО; ЛРО;	
US-PGPUB; EPO; IPO; DERWENT USPAT; US-PGPUB; non-porous) and (((surface substrate) with (("not" near porous) non-porous)) and (rough vith (("not" near porous)) and ((surface substrate) with (("not" near porous)) and (((surface substrate) with (("not" near porous)) and (rough vith (("not" near porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous)) and (surface substrate) with (("not" near porous)) and ((surface substrate) with (("not" near porous)) and (surface substrate) with (("not" near porous)) and (surface substrate) with (("not" near porous)) and (surface substrate) with (("not" near porous)) DERWENT US-PGPUB; EPO; IPO; DERWENT US-PGPUB; EPO; IP					
- 65 ((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and ((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((((((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((((((((((((((((((((((((((((((((((-	1009	((surface substrate) with (("not" near porous) non-porous)) and laser	USPAT;	2004/02/26 15:50
- 65 (((surface substrate) with (("not" near porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous) usparts) (USPAT; USPGPUB; EPO; JPO; with (("not" near porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate) with (("not" near porous)) and (rough roughness)) and ((((surface substrate) with (("not" near porous)) and (rough roughness)) and (((((surface substrate) with (("not" near porous)) and (rough roughness)) and (((((((surface substrate) with (("not" near porous)) and (((((((((((((((((((((((((((((((((((
- 65 ((((surface substrate) with (("not" near porous)) and (rough roughness)) and (((((surface substrate) with (("not" near porous)) ron-porous)) and (((((surface substrate) with (("not" near porous)) and ((((((surface substrate) with (("not" near porous)) and (rough roughness)) and (((((((((surface substrate) with (("not" near porous)) and (rough roughness)) and (((((((((((((((((((((((((((((((((((
roughness)) and ((((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate) with (("not" near porous) non-porous)) and laser) (((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((((surface substrate) with (("not" near porous) non-porous)) and (rough non-porous)) and (adsor\$5 desor\$5 ioniz\$40) and ((((((surface substrate) with (("not" near porous) non-porous)) and (rough non-porous)) and (adsor\$5 desor\$5 ioniz\$40) and (((((((((((((((((((((((((((((((((((
non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and ((((surface substrate) with (("not" near porous) non-porous)) and laser)	-	65			2004/02/26 16:30
with (("not" near porous) non-porous)) and laser) (((((((((((((((((((((((((((((((((((-	
- 15 ((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and ((((surface substrate) with (("not" near porous) non-porous)) and ((((surface substrate) with (("not" near porous) non-porous)) and (((((surface substrate) with (("not" near porous) non-porous)) and (((((surface substrate) with (("not" near porous) non-porous)) and (((((surface substrate) WS-PGPUB; EPO; JPO; DERWENT US-PGPUB;					
roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate) with (("not" near porous) non-porous)) and laser)) and analyte 2 6399177.pn. 1 Sunner-Jan\$.in. 2 Sunner-Jan\$.in. 2 US-PGPUB; EPO; JPO; DERWENT					
non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate) with (("not" near porous) non-porous)) and laser)) and analyte 2 dispersion of the property of the prop	-	15			2004/02/26 16:19
with (("not" near porous) non-porous)) and laser)) and analyte - 2 6399177.pn. DERWENT USPAT; US-PGPUB; EPO, JPO, DERWENT USPAT; USPAT; USPAT; USPAT; USPAT; USPAT; USPAT;					
- 2 6399177.pn. USPAT; US-PGPUB; EPO, JPO, DERWENT US-PGPUB; EPO, JPO, DERWENT US-PGPUB; EPO, JPO, DERWENT USPAT; 2004/02/26 16:2					
US-PGPUB; EPO, JPO; DERWENT USPAT; 2004/02/26 16:2					
EPO, JPO; DERWENT USPAT; US-PGPUB; EPO, JPO; DERWENT US-PGPUB; EPO, JPO; DERWENT USPAT; USPAT; 2004/02/26 16:2	-	2	6399177.pn.		2004/02/26 16:14
- 1 Sunner-Jan\$.in. DERWENT USPAT; US-PGPUB; EPO, JPO; DERWENT USPAT; USPAT; US-PGPUB; EPO, JPO; DERWENT USPAT; US-PGPUB; EPO, JPO; DERWENT USPAT; US-PGPUB; EPO, JPO; DERWENT USPAT; USPAT; USPAT; USPAT; USPAT; USPAT; USPAT;					
- 1 Sunner-Jan\$.in. USPAT; US-PGPUB; EPO, JPO, DERWENT US-PGPUB; EPO, JPO; DERWENT USPAT; 2004/02/26 16:2					
US-PGPUB; EPO, IPO, DERWENT USPAT; 2004/02/26 16:2 US-PGPUB; EPO, IPO, DERWENT US-PGPUB; EPO, IPO, DERWENT US-PGPUB; EPO, IPO, DERWENT US-PGPUB; EPO, IPO, DERWENT USPAT; 2004/02/26 16:2 USPAT; 2004/02/26 USPAT;					2004/02/04 16 10
EPO, JPO; DERWENT USPAT; US-PGPUB; EPO, JPO; DERWENT	-	1	Sunner-Jan\$.in.		2004/02/26 16:19
- 1 Alimpiev-Sergey\$.in. DERWENT USPAT; 2004/02/26 16:2 US-PGPUB; EPO, JPO, DERWENT USPAT; 2004/02/26 16:2 US-PGPUB; EPO, JPO, DERWENT USPAT; 2004/02/26 16:2 USPAT; 2004/02/26 USPAT					
- 1 Alimpiev-Sergey\$.in. USPAT; US-PGPUB; EPO, JPO, DERWENT USPAT; 2004/02/26 16:2					
US-PGPUB; EPO; JPO; DERWENT USPAT; 2004/02/26 16:2		1	A1:: C C :		2004/02/26 16:20
EPO; JPO; DERWENT USPAT; 2004/02/26 16:2	-	1	Alimpiev-Sergeys.in.		2004/02/20 10:20
DERWENT 1 Nikiforovl-Sergey\$.in. DERWENT USPAT; 2004/02/26 16:2					
- 1 Nikiforovl-Sergey\$.in. USPAT; 2004/02/26 16:2					
		1	Mile formal Sargary in		2004/02/26 16:20
I II DODITO	-	1	Mikitotovi-Seigeyä.iii.	US-PGPUB;	2004/02/20 10.20
EPO; JPO; DERWENT					
	_	າ	((((surface substrate) with (("not" near norms) non norms)) and (rough		2004/02/27 17:09
roughness)) and (((surface substrate) with (("not" near porous)) and (US-PGPUB;	•	2			2004/02/27 17.09
non-porous)) and (((surface substrate) with ((not near porous) and ((surface substrate) lepo; JPO;					
with (("not" near porous) non-porous)) and laser)) and DERWENT	i				
(250/423R,424,425,423P.ccls.)				PERMITAI	
	_	0		IISPAT.	2004/02/26 16:25
		,	roughness)) and (((surface substrate) with (("not" near porous)	US-PGPUB;	200-102/20 10.25
I FOURTHESS IT AND THE SUBSITIATE SUBSITIATE I WITH HE THOUGHT TO FOURT TO FOURT THE TENSOR THE TEN					
			with (("not" near porous) non-porous)) and laser)) and (laser with	DERWENT	
non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate) EPO; JPO;			puls\$3)	22	

	,			
-	2	(((surface substrate) with (("not" near porous) non-porous)) and	USPAT;	2004/02/26 16:30
		(((surface substrate) with (("not" near porous) non-porous)) and (rough	US-PGPUB;	
i	i	roughness)) and (((surface substrate) with (("not" near porous)	ЕРО; ЈРО;	
		non-porous)) and laser)) and (250/423R,424,425,423P.ccls.)	DERWENT	
-	187	(surface near rough\$4) same (non-porous ("not" adj porous))	USPAT;	2004/02/26 17:23
	İ		US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
	30	((surface near rough\$4) same (non-porous ("not" adj porous))) and laser	USPAT;	2004/02/26 19:01
1] 30	((surface field roughty) suffic (fion-porous (fiot-adj porous))) and faser	US-PGPUB;	2004/02/20 17.01
1	-		ЕРО; ЛРО;	
	ļ			
	١ .	(//	DERWENT	2004/02/26 17:24
1 -	2	(((surface near rough\$4) same (non-porous ("not" adj porous))) and	USPAT;	2004/02/26 17:24
		laser) and analyte	US-PGPUB;	
			ЕРО; ЈРО;	,
			DERWENT	
-	45	((surface near rough\$4) same (non-porous ("not" adj porous))) and	USPAT;	2004/02/26 18:57
		(nanometer nm)	US-PGPUB;	
			ЕРО; ЛРО;	
1			DERWENT	
-	12	(((surface near rough\$4) same (non-porous ("not" adj porous))) and	USPAT;	2004/02/26 17:44
	1	laser) and (nanometer nm)	US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
_	138	(non-porous ("not" adj porous)) with (rough roughness)	USPAT;	2004/02/26 18:56
		(US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
1_	27	((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/27 09:59
	2'	desor\$5 ioniz\$4)	US-PGPUB;	2004/02/27 07.57
		desorationizati	ЕРО; ЛРО;	
	16	(((,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	DERWENT	2004/02/26 10:01
-	16	(((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/26 19:01
		desor\$5 ioniz\$4)) and (nanometer nm)	US-PGPUB;	7
	1		EPO; JPO;	
1		(III) 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	DERWENT	2004/02/26 10:50
-	1	((((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/26 18:59
		desor\$5 ioniz\$4)) and (nanometer nm)) and (mass adj spectromet\$2)	US-PGPUB;	
			ЕРО; ЈРО;	
	_		DERWENT	0004/02/27 17 17
-	2	(((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/26 18:59
		desor\$5 ioniz\$4)) and (mass adj spectromet\$2)	US-PGPUB;	
1			ЕРО; ЈРО;	
1			DERWENT	
-	2	((non-porous ("not" adj porous)) with (rough roughness)) and (mass adj	USPAT,	2004/02/26 18:59
		spectromet\$2)	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	6	(((((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/26 19:03
		desor\$5 ioniz\$4)) and (nanometer nm)) and laser	US-PGPUB;	
1		, , , , , , , , , , , , , , , , , , , ,	ЕРО; ЛРО;	
			DERWENT	
-	1943	laser same analyte	USPAT;	2004/02/27 09:59
	1,743		US-PGPUB;	
			EPO; JPO;	
			DERWENT	
	34	(laser same analyte) and ((surface substrate) with (("not" near porous)	USPAT;	2004/02/27 11:28
1	34	non-porous))	US-PGPUB;	2007102121 11.20
		inon-porous))		
1			ЕРО; ЛРО;	
L	L	l	DERWENT	

	1		**************************************	[= 0.0 4 10 = 10 = 10 = 10 = 10
-	13	((laser same analyte) and ((surface substrate) with (("not" near porous) non-porous))) and rough\$4	USPAT; US-PGPUB;	2004/02/27 11:11
			EPO; JPO;	
	9	(((locar come analyte) and ((a)) foce a) betrate) with ((!not!!	DERWENT	2004/02/27 11:02
-	9	(((laser same analyte) and ((surface substrate) with (("not" near porous))	USPAT; US-PGPUB;	2004/02/27 11:02
		non-porous))) and rough\$4) and (nanometer nm nano-rough\$4)	,	
1			EPO; JPO; DERWENT	
	0	20020187312.URPN.	USPAT	2004/02/27 10:59
	13	(((laser same analyte) and ((surface substrate) with (("not" near porous)	USPAT;	2004/02/27 10:39
		non-porous))) and rough\$4) and Laser	US-PGPUB;	2004/02/27 11.07
		livii porodo))) drid roughto i) drid Edubor	ЕРО; ЈРО;	
			DERWENT	
l <u>-</u>	9	(((((laser same analyte) and ((surface substrate) with (("not" near	USPAT;	2004/02/27 11:12
	1	porous) non-porous))) and rough\$4) and (nanometer nm nano-rough\$4))	US-PGPUB;	
:		and Laser	ЕРО; ЛРО;	;
			DERWENT	
-	8507	((surface substrate) with (("not" near porous) non-porous))	USPAT;	2004/02/27 11:11
			US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	98	(((surface substrate) with (("not" near porous) non-porous))) and	USPAT;	2004/02/27 11:22
		(rough\$4 with (nanometer nm nano- nano))	US-PGPUB;	
			ЕРО; ЛРО;	
	12	/// C 1 4 4 2 3d //D 4B	DERWENT	2004/02/27 11 27
-	42	((((surface substrate) with (("not" near porous) non-porous))) and	USPAT;	2004/02/27 11:27
		(rough\$4 with (nanometer nm nano- nano))) and Laser	US-PGPUB; EPO; JPO;	
			DERWENT	
_	15	((((((surface substrate) with (("not" near porous) non-porous))) and	USPAT;	2004/02/27 11:18
		(rough\$4 with (nanometer nm nano- nano))) and Laser) and (adsor\$5	US-PGPUB;	200 1702/27 11:10
		desor\$5 ioniz\$5 analyte)	ЕРО; ЛРО;	
		, , ,	DERWENT	
-	3	((((((surface substrate) with (("not" near porous) non-porous))) and	USPAT;	2004/02/27 11:21
		(rough\$4 with (nanometer nm nano- nano))) and Laser) and (laser with	US-PGPUB;	
		(desor\$5 ioniz\$5 analyte))	ЕРО; ЛРО;	
			DERWENT	
-	23253	(gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm)	USPAT;	2004/02/27 11:28
			US-PGPUB;	•
-			EPO; JPO;	
	241	//case4	DERWENT	2004/02/27 11 25
-	241	((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm)) and ((surface substrate) with (("not" near porous) non-porous))	USPAT; US-PGPUB;	2004/02/27 11:25
		((surface substrate) with ((not near porous) non-porous))	EPO; JPO;	
			DERWENT	
_	130	(((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm))	USPAT;	2004/02/27 11:29
		and ((surface substrate) with (("not" near porous) non-porous))) and	US-PGPUB;	
	1	laser	ЕРО; ЛРО;	
			DERWENT	
-	0	((((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm))	USPAT;	2004/02/27 11:25
		and ((surface substrate) with (("not" near porous) non-porous))) and	US-PGPUB,	
		laser) and (250/423R,424,425,423P.ccls.)	ЕРО; ЈРО;	
	_		DERWENT	
-	3	(((((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm))	USPAT;	2004/02/27 11:29
		and ((surface substrate) with (("not" near porous) non-porous))) and	US-PGPUB;	
		laser) and (250/\$.ccls.)	EPO; JPO;	
	,	(((((aurfaga guhatrata) with ((lleatill against agains	DERWENT	2004/02/27 11 22
-	3	(((((surface substrate) with (("not" near porous) non-porous))) and (rough\$4 with (nanometer nm nano- nano))) and Laser) and analyte	USPAT;	2004/02/27 11:29
		(roughtor with (nanometer init hano- nano))) and Laser) and analyte	US-PGPUB; EPO; JPO;	
			DERWENT	
	l	L	NULTITUDE I	l,

-	43545	metal with (rough\$4 nano-rough\$4 nano- nanometer nm)	USPAT;	2004/02/27 11:29
			US-PGPUB; EPO; JPO;	
			DERWENT	
1_	663	(metal with (rough\$4 nano-rough\$4 nano- nanometer nm)) and analyte	USPAT;	2004/02/27 11:29
-	003	(mean with (roughty hano-roughty hano- hanometer him)) and analyte	US-PGPUB;	2004/02/27 11.29
			EPO; JPO;	
			DERWENT	
-	397	((metal with (rough\$4 nano-rough\$4 nano- nanometer nm)) and analyte)	USPAT;	2004/02/27 11:29
		and laser	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	28	(((metal with (rough\$4 nano-rough\$4 nano- nanometer nm)) and	USPAT;	2004/02/27 13:29
		analyte) and laser) and (250/\$.ccls.)	US-PGPUB;	
			ЕРО; ЈРО;	
	1		DERWENT	
-	21287	metal with rough\$4	USPAT;	2004/02/27 14:48
			US-PGPUB;	
			ЕРО; ЛРО;	
		(DERWENT	2004/02/25 : : 55
-	1113	(metal with rough\$4) and ((nanometer nano nm) same rough\$4)	USPAT;	2004/02/27 14:53
			US-PGPUB;	
			EPO; JPO; DERWENT	
	890	(metal with rough\$4) and (laser with (in situ))	USPAT;	2004/02/27 13:53
-	890	(metal with foughts4) and (laser with (m situ))	US-PGPUB;	2004/02/27 13.33
			EPO; JPO;	
	:		DERWENT	
_	155	((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and	USPAT;	2004/02/27 13:39
		((metal with rough\$4) and (laser with (in situ)))	US-PGPUB;	200 1102121 13.37
		((110111) 1111 (11011) 1111 (11111) 1111 (11111) 1111	ЕРО; ЛРО;	
			DERWENT	
-	27	(((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and	USPAT;	2004/02/27 14:48
		((metal with rough\$4) and (laser with (in situ)))) and analyte	US-PGPUB;	
			ЕРО; ЈРО;	,
			DERWENT	
-	198	(rough\$4 nano-rough\$4) with (("not" near porous) non-porous)	USPAT;	2004/02/27 14:02
			US-PGPUB;	
			ЕРО; ЛРО;	
	22	((rough\$4 none rough\$4) with ((!!not!! noon no)	DERWENT	2004/02/27 12:55
-	22	((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser	USPAT; US-PGPUB;	2004/02/27 13:55
			ЕРО; ЛРО;	!
			DERWENT	
_	3	((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and	USPAT;	2004/02/27 13:53
		analyte	US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
-	2	(((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and	USPAT;	2004/02/27 13:54
		laser) and (((rough\$4 nano-rough\$4) with (("not" near porous)	US-PGPUB;	
		non-porous)) and analyte)	ЕРО; ЛРО;	
			DERWENT	
-	21287	(rough\$4 nano-rough\$4) with (metal)	USPAT;	2004/02/27 13:55
			US-PGPUB;	
			ЕРО; ЛРО;	
	2654	((rough\$4 pape rough\$4) with (motal)) and laser	DERWENT	2004/02/27 14:02
-	2034	((rough\$4 nano-rough\$4) with (metal)) and laser	USPAT; US-PGPUB;	2004/02/27 14:03
			EPO; JPO;	
			DERWENT	
	L			L

	122		Troper	0004/00/07 12 55
-	133	((rough\$4 nano-rough\$4) with (metal)) and analyte	USPAT;	2004/02/27 13:55
İ			US-PGPUB;	
			EPO; JPO;	
	100		DERWENT	2004/02/05 12 55
-	109	(((rough\$4 nano-rough\$4) with (metal)) and laser) and (((rough\$4	USPAT;	2004/02/27 13:55
		nano-rough\$4) with (metal)) and analyte)	US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
-	10	((((rough\$4 nano-rough\$4) with (metal)) and laser) and (((rough\$4	USPAT;	2004/02/27 14:01
		nano-rough\$4) with (metal)) and analyte)) and 250/\$.ccls.	US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
-	14	(mass near spectromet\$2) same ((rough\$4 nano-rough\$4 nano) with	USPAT;	2004/02/27 14:13
		(("not" near porous) non-porous metal))	US-PGPUB;	
			EPO; JPO;	
	_		DERWENT	
-	10	((mass near spectromet\$2) same ((rough\$4 nano-rough\$4 nano) with	USPAT;	2004/02/27 14:03
		(("not" near porous) non-porous metal))) and laser	US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	10	(((mass near spectromet\$2) same ((rough\$4 nano-rough\$4 nano) with	USPAT;	2004/02/27 14:46
		(("not" near porous) non-porous metal))) and laser) and ((nanometer	US-PGPUB;	
		nano nm))	ЕРО; ЈРО;	
			DERWENT	
-	8200	((nanometer nano nm) with rough\$4)	USPAT;	2004/02/27 14:49
			US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
-	2712	(((nanometer nano nm) with rough\$4)) and laser	USPAT;	2004/02/27 14:53
			US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	221	(((nanometer nano nm) with rough\$4)) and analyte	USPAT;	2004/02/27 14:13
			US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	137	(((((nanometer nano nm) with rough\$4)) and laser) and ((((nanometer	USPAT;	2004/02/27 14:13
		nano nm) with rough\$4)) and analyte)	US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	23		USPAT;	2004/02/27 14:13
		nano nm) with rough\$4)) and analyte)) and ((mass near spectromet\$2)	US-PGPUB;	
		(ion adj mobility))	ЕРО; ЈРО;	
			DERWENT	
-	16	(metal with rough\$4) same laser same analyte	USPAT;	2004/02/27 14:49
			US-PGPUB;	
			ЕРО, ЛРО,	
			DERWENT	
-	15	((metal with rough\$4) same laser same analyte) and (nanometer nano	USPAT;	2004/02/27 14:52
		nm nano-)	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	0	nano-rough\$4 with analyte	USPAT;	2004/02/27 14:52
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	150	rough\$4 with analyte	USPAT;	2004/02/27 14:53
1	İ		US-PGPUB;	
			EPO; JPO;	
		<u> </u>	DERWENT	l

-	77	(rough\$4 with analyte) and laser	USPAT; US-PGPUB;	2004/02/27 14:53
			EPO; JPO;	
	57	((rough\$4 with analyte) and laser) and (nanometer nano nano- nm)	DERWENT USPAT;	2004/02/27 15:03
-	3/	(troughter with analyte) and taser) and (nanometer namo namo- nm)	USPAT; US-PGPUB;	2004/02/27 13:03
			EPO; JPO;	
	5	((improv\$4 increas\$4) near3 analyte) with (rough\$4)	DERWENT	2004/02/27 16:41
<u> </u>	,	((improva4 increasa4) hears anaryte) with (rougha4)	USPAT;	2004/02/27 16:41
			US-PGPUB; EPO; JPO;	
ĺ			DERWENT	
	0	20020187312.URPN.	USPAT	2004/02/27 15:52
	39	Fonash-Stephen\$.in.	USPAT;	2004/02/27 15:53
	37	1 Olash-Stephens.m.	US-PGPUB;	2004/02/27 13.33
			EPO; JPO;	
			DERWENT	
_	6	Fonash-Stephen\$.in. and (rough\$4)	USPAT;	2004/02/27 15:53
		1 2 man Diephone.in. and (100gnet)	US-PGPUB;	200 TO EI E I 13.33
			EPO; JPO;	
			DERWENT	
_	93	((improv\$4 increas\$4) near3 ion) with (rough\$4)	USPAT;	2004/02/27 15:55
		((improve + increase +) hears fort) with (roughles)	US-PGPUB;	2004/02/27 15.55
			ЕРО; ЛРО;	
			DERWENT	
_	26	(((improv\$4 increas\$4) near3 ion) with (rough\$4)) and laser	USPAT;	2004/02/27 16:23
		(((Improve v moreage v) nears fony what (roughle v)) and tases	US-PGPUB;	200 1/02/27 10:25
			EPO; JPO;	
			DERWENT	
_	359	((mass adj spectromet\$2) (ion adj mobility)) same rough\$4	USPAT;	2004/02/27 16:24
		((and of continuous) (and	US-PGPUB;	200 11 02/21 10:21
			ЕРО; ЈРО;	
			DERWENT	
-	135	(((mass adj spectromet\$2) (ion adj mobility)) same rough\$4) and laser	USPAT;	2004/02/27 16:03
			US-PGPUB,	
			EPO, JPO,	
			DERWENT	
-	54	((((mass adj spectromet\$2) (ion adj mobility)) same rough\$4) and laser)	USPAT;	2004/02/27 16:23
		and analyte	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	3406	(ion analyte) with (rough\$4)	USPAT;	2004/02/27 16:23
			US-PGPUB;	
			ЕРО; ЈРО;	
	50.5	(4) 14 2 14 4 14 14 14	DERWENT	2004/02/27 22
-	705	((ion analyte) with (rough\$4)) and laser	USPAT;	2004/02/27 16:42
			US-PGPUB;	
			EPO; JPO;	
	301	((ion analyta) with (sough \$4)) and ((mass add) and (\$40) ("	DERWENT	2004/02/27 14 24
-	281	((ion analyte) with (rough\$4)) and ((mass adj spectromet\$2) (ion adj	USPAT;	2004/02/27 16:24
		mobility))	US-PGPUB;	
	:		EPO; JPO; DERWENT	
_	97	(((ion analyte) with (rough\$4)) and laser) and (((ion analyte) with	USPAT;	2004/02/27 16:24
_	7/	(((foli analyte) with (rough\$4)) and faser) and (((foli analyte) with (rough\$4)) and ((mass adj spectromet\$2) (ion adj mobility)))	USPAT; US-PGPUB;	2004/02/27 10:24
		(1045147) and ((111455 adj spectromety2) (1011 adj moothity))	ЕРО; ЛРО;	
:			DERWENT	
_	59	((((ion analyte) with (rough\$4)) and laser) and (((ion analyte) with	USPAT;	2004/02/27 16:25
		((rough\$4)) and ((mass adj spectromet\$2) (ion adj mobility)))) and	US-PGPUB;	200 1102121 10.23
		(nanometer nm)	ЕРО; ЛРО;	
		, , , , , , , , , , , , , , , , , , , ,	DERWENT	
	·			

	51	(((((ion analyte) with (rough\$4)) and laser) and (((ion analyte) with	USPAT;	2004/02/27 16:32
		(rough\$4)) and ((mass adj spectromet\$2) (ion adj mobility)))) and	US-PGPUB:	100 0227 10.52
		(nanometer nm)) and (silicon carbon polymer graphite)	ЕРО; ЛРО;	
		,, (, , , , , , , , , , , , , , , , ,	DERWENT	
-	1	((enhanc\$4) near3 analyte) with (rough\$4)	USPAT;	2004/02/27 16:40
			US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	·6	((enhanc\$4) near3 ion) with (rough\$4)	USPAT;	2004/02/27 16:41
			US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
-	32	((analyte) with (rough\$4)) same (nanometer nm nano nano-)	USPAT;	2004/02/27 16:42
1			US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	26	(((analyte) with (rough\$4)) same (nanometer nm nano nano-)) and laser	USPAT;	2004/02/27 16:43
			US-PGPUB;	
			ЕРО; ЈРО;	
:		(1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.1.	DERWENT	2004/02/07 16 40
-	3	((absorb with analyte) same rough\$4)	USPAT;	2004/02/27 16:49
			US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	